

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q96338

Hitoshi ISHIZAKA, et al.

Appln. No.: 10/591,330

Group Art Unit: 1746

Confirmation No.: 9420

Examiner: Not yet determined

Filed: August 31, 2006

For: CLEANING MEMBER FOR SEMICONDUCTOR APPARATUS AND PROCESS FOR PRODUCING  
THE SAME

**SUBMISSION OF ENGLISH TRANSLATION OF INTERNATIONAL PRELIMINARY  
REPORT ON PATENTABILITY**

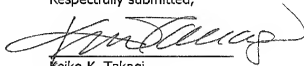
**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

For the Examiner's convenience, enclosed herewith is a copy of an English translation of the International Preliminary Report on Patentability received in reference to the above-identified application. It is noted that the four (4) references cited in the Report were previously listed on the PTO/SB/08 form submitted with the Information Disclosure Statement filed in the U.S. Patent and Trademark Office on August 31, 2006, along with copies of the foreign references.

Respectfully submitted,



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**65565**

CUSTOMER NUMBER

Date: August 22, 2007